

2-25-03 mm
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FIRST PRELIMINARY AMENDMENT

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TO THE ASSISTANT COMMISSIONER FOR PATENTS:

In the Claims:

Please add the following new claims.

A1

23. A method, comprising:

forming a first layer of spin-on glass on a substrate;

depositing a first dielectric on the first layer;

forming a second layer of spin-on glass on the first dielectric; and

planarizing the second layer of spin-on glass.

24. The method of claim 23 wherein forming the first layer of spin-on glass comprises depositing a siloxane-based spin-on glass on the substrate.

25. The method of claim 23 wherein forming the first layer of spin-on glass comprises depositing a polyimide spin-on glass on the substrate.

26. The method of claim 23 wherein forming the first layer of spin-on glass comprises depositing a polymethylmethacrylate spin-on glass on the substrate.

27. The method of claim 23 wherein forming the first layer of spin-on glass comprises curing the first layer at 425°C.

28. The method of claim 23, further comprising:
forming a second dielectric on the substrate before forming the first layer of spin-on glass; and
forming the first layer of spin-on glass on the second dielectric.